

PATENT
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Serial No.: 10/736,386)) Conf. No.: 6227
Filed: December 15, 2003))
Title: **METHOD FOR CALCULATING**)
 HIGH-RESOLUTION WAFER)
 PARAMETER PROFILES)
Inventor: Whitefield et al.))
Art Unit: 2128))
Examiner: Kimberly A. Thornwell))
Atty. Ref: 03-1345))

RESPONSE TO THE OFFICE ACTION MAILED DECEMBER 26, 2006

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In the matter of the above-identified application and in response to the Office Action mailed December 26, 2006, kindly enter the following amendments and consider the following remarks toward reconsideration of the present application.